

PATENT  
3430-0140P

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**INFORMATION SHEET**



Applicant: Byung-Young AN

Appl. No.: New Application

Filed: December 21, 2000

For: DRY ETCHING METHOD AND APPARATUS FOR USE  
IN THE LCD DEVICE

Priority Claimed Under 35 U.S.C. § 119 and/or § 120:

2000-8044 KOREA February 19, 2000

Send Correspondence to:


BIRCH, STEWART, KOLASCH & BIRCH, LLP or **CUSTOMER NO. 2292**  
P.O. Box 747  
Falls Church, VA 22040-0747  
(703) 205-8000

The above information is submitted to advise the U.S.P.T.O. of all relevant facts in connection with the present application.

A timely executed Declaration in accordance with 37 C.F.R. § 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By   
Gary D. Yacura  
Reg. No. 35,416  
P.O. Box 747  
Falls Church, VA 22040-0747  
(703) 205-8000

GDY/AL:lms  
3430-140P